



Patent  
Attorney's Docket No. 1015290-000500

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of )  
S. Y. LI et al. ) Group Art Unit: 1763  
Application No.: 09/820,695 ) Examiner: A. W. Olsen  
Filed: March 30, 2001 ) Confirmation No.: 4162  
For: METHOD OF PLASMA ETCHING )  
LOW-K DIELECTRIC MATERIALS )

AMENDMENT

Entered with RCE 5/23/06  
MW 5/26/06

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is a response to the Official Action dated February 23, 2006. Please  
amend the above-identified application as follows: